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PATENT

Attorney Docket No. 008401 05

15535 U.S. PTO
10/646528
08/22/03

In re Application of: Kenneth S. Collins, Hiroji Hanawa, Kartik Ramaswamy,
Andrew Nguyen, Amir Al-Bayati, Biagio Gallo, and Gonzalo
Antonio Monroy

Entitled: PLASMA IMMERSION ION IMPLANTATION APPARATUS INCLUDING
AN INDUCTIVELY COUPLED PLASMA SOURCE HAVING LOW
DISSOCIATION AND LOW MINIMUM PLASMA VOLTAGE

Attorney Docket No.: 008401 05

Sir:

Enclosed herewith for filing is a patent application entitled PLASMA IMMERSION ION IMPLANTATION SYSTEM INCLUDING AN INDUCTIVELY COUPLED PLASMA SOURCE HAVING LOW DISSOCIATION AND LOW MINIMUM PLASMA VOLTAGE including 139 pages of specification, 58 claims and abstract, and 85 sheets of drawings (Figures 1-112).

This application is being filed missing parts and specifically without a declaration by the inventors and without a filing fee. The application is being filed in the names of the inventors, Kenneth S. Collins, Hiroji Hanawa, Kartik Ramaswamy, Andrew Nguyen, Amir Al-Bayati, Biagio Gallo, and Gonzalo Antonio Monroy.

Please address all correspondence to:

Patent Counsel, M/S 2061
Legal Affairs Dept.
Applied Materials, Inc.
P.O. Box 450-A
Santa Clara, CA 95035

Please direct all telephone inquiries to: Robert M. Wallace (805) 644-4035

Dated: August 22, 2003

Respectfully submitted,

Robert M. Wallace
Robert M. Wallace
Reg. No. 29,119
Attorney for Applicant(s)